L Number	Hits	Search Text	DB	Time stamp
1		451/\$.ccls.	USPAT;	2003/01/14 10:26
<b> </b>			US-PGPUB;	
}			EPO; JPO;	
			DERWENT;	
	*		IBM_TDB	
2	1675290	wafer or wafers or substrate or substrates	USPAT;	2003/01/14 10:26
			US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
,	1450750	drum or culindor	IBM_TDB	2002/01/14 10 05
3	1439/50	drum or cylinder	USPAT; US-PGPUB;	2003/01/14 10:26
			EPO; JPO;	
			DERWENT;	
			IBM TDB	
4	65	dressing with laser	USPAT;	2003/01/14 10:26
			US-PGPUB;	
1			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
5	18502		USPĀT;	2003/01/14 10:28
		substrates ) with (drum or cylinder)	US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
6	379	451/\$.ccls. and ((wafer or wafers or	USPAT;	2003/01/14 10:27
]		substrate or substrates ) with (drum or	US-PGPUB;	
-		cylinder))	EPO; JPO;	
			DERWENT;	
7	_	//51/S cole and //wafar ar vafara ar	IBM_TDB	2003/01/14 10:03
'	١	(451/\$.ccls. and ((wafer or wafers or substrate or substrates ) with (drum or	USPAT;	2003/01/14 10:27
		cylinder))) and (dressing with laser)	US-PGPUB; EPO; JPO;	
		cylinder/// and (dressing with laser)	DERWENT;	
			IBM TDB	
8	1	((wafer or wafers or substrate or	USPAT;	2003/01/14 10:27
		substrates ) with (drum or cylinder)) and	US-PGPUB;	
		(dressing with laser)	EPO; JPO;	
1			DERWENT;	
			IBM_TDB	
9	10474	(wafer or wafers or substrate or	USPĀT;	2003/01/14 10:28
		substrates ) near5 (drum or cylinder)	US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
110	10474	//wafan an wafan an anta-ta-ta-ta-ta-ta-ta-ta-ta-ta-ta-ta-ta-t	IBM_TDB	2002/01/14 12 22
10	10474	((wafer or wafers or substrate or	USPAT;	2003/01/14 10:29
		substrates ) near5 (drum or cylinder)) and ((wafer or wafers or substrate or	US-PGPUB;	
		substrates ) with (drum or cylinder))	EPO; JPO; DERWENT;	
			IBM TDB	
11	214	((wafer or wafers or substrate or	USPAT;	2003/01/14 10:29
	2.1	substrates ) near5 (drum or cylinder)) and	US-PGPUB;	
		451/\$.ccls.	EPO; JPO;	
			DERWENT;	
			IBM_TDB	
12	294	(451/254).CCLS.	USPĀT;	2003/01/14 10:39
			US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
		. , ,	IBM_TDB	
13	23113	rotary adj drum	USPAT;	2003/01/14 10:40
			US-PGPUB;	
1			EPO; JPO;	
			DERWENT;	
14	1084	(wafer or wafers or substrate or	<pre>IBM_TDB USPAT;</pre>	2002/01/14 10:40
1 7	1004	substrates ) and (rotary adj drum)	US-PGPUB;	2003/01/14 10:40
	]	substraces, and (rotary adj drum)	EPO; JPO;	
	1		DERWENT;	
1			IBM TDB	
<u>_</u>				

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15	15	((wafer or wafers or substrate or	USPAT;	2003/01/14	10:40
		substrates ) and (rotary adj drum)) and	US-PGPUB;		
		451/\$.ccls.	EPO; JPO;		
			DERWENT;		
			IBM TDB		i